

2834

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of
Masuyuki KIKUSHIMA et al.
Application No.: 09/120,806
Filed: July 23, 1998



Group Art Unit: 2834
Examiner: M. Budd
Docket No.: 101151

#18 / Amended
A. Juel
7/19/00

For: PIEZO-ELECTRIC RESONATOR AND MANUFACTURING METHOD THEREOF

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

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In response to the Office Action dated May 10, 2000, please amend the above identified application as follows:

IN THE DRAWINGS:

Please amend Figs. 1(b) and 11 as set forth in the attached Request for Approval of Drawing Corrections.

IN THE SPECIFICATION:

Page 7, line 10, after "1b." insert --The substrate 1b has a thickness b that is larger than the thickness a of the substrate 1a.--

REMARKS

Claims 1-6, 8, 10-13, 15-22 and 30-37 are pending. By this Amendment, the specification and Figs. 1(b) and 11 are amended to correct minor informalities pointed out by the Office Action. In particular, the specification and Figs. 1(b) and 11 are amended to further clarify, for example, that the substrate 1b has a larger thickness than that of the